

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080
Satoshi SHIBATA : Confirmation Number: 2300
Application No.: 10/557,746 : Group Art Unit: 2813
Filed: November 21, 2005 : Examiner: Crawford, Latanya N
For: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 14, 2009, having a three-month shortened statutory period for response set to expire October 14, 2009, please amend the above-identified application as follows.